

<b>Search Notes (continued)</b>	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/780,990	BENTLEY ET AL.
Examiner	Art Unit	
Sun J. Lin	2825	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
716	11	2/26/2007	JSL
716	1,15	2/26/2007	JSL
700	121	2/26/2007	JSL